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Characterization of luminescent samarium doped HfO₂ coatings synthesized by spray pyrolysis technique

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Abstract

Trivalent samarium (Sm³+) doped hafnium oxide (HfO₂) films were deposited using the spray pyrolysis deposition technique. The films were deposited on Corning glass substrates at temperatures ranging from 300 to 550 °C using chlorides as raw materials. Films, mostly amorphous, were obtained when deposition temperatures were below 350 °C. However, for temperatures higher than 400 °C, the films became polycrystalline, presenting the HfO₂ monoclinic phase. Scanning electron microscopy of the films revealed a rough surface morphology with spherical particles. Also, electron energy dispersive analysis was performed on these films. The photoluminescence and cathodoluminescence characteristics of the HfO₂: SmCl₃ films, measured at room temperature, exhibited four main bands centred at 570, 610, 652 and 716 nm, which are due to the well-known intra-4f transitions of the Sm³+ ion. It was found that the overall emission intensity rose as the deposition temperature was increased. Furthermore, a concentration quenching of the luminescence intensity was also observed.

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1. Introduction

Transition metal oxides, such as hafnium oxide (HfO₂), have attracted significant attention because of their potential applications. HfO₂ can be used as a gas sensor [1] and waveguide [2], as well as a protective coating, due to its thermal stability and hardness [3, 4]. Up to now, one of the most important applications of HfO₂ is probably in the microelectronic industry. HfO2 is studied as a high-k gate dielectric layer with a relatively high index of refraction and a wide energy band gap. These properties make HfO₂ a good candidate for applications in metal-oxide-semiconductor devices for the next generation [5,6]. The wide band gap of HfO₂ makes it transparent over a wide spectroscopic range: from the ultraviolet to the mid-infrared [7]. Furthermore, HfO₂ has been employed in optical coating applications such as high-reflectivity mirrors, anti-reflection coatings, filters and beamsplitters [8, 9]. In addition, the large energy band gap

and the low phonon frequencies make HfO₂ an appropriate host matrix for being doped with rare earth activators [10, 11]. Efficient luminescent materials have wide applications in electroluminescent flat panel displays; colour plasma display panels, scintillators, cathode ray tubes, fluorescent lamps, lasers, etc. In recent years the study of luminescent materials based on HfO2 has been intensified. Some groups have studied the optical properties of doped and undoped HfO2 [12–14]. Specifically, some studies on rare earth and Mn doped HfO₂ films have been recently reported [12, 15–17]. One of the most important properties of rare earth ions doped compounds is the very narrow absorption and emission band arising from the parity-forbidden intraconfigurational 4f-4f transitions. As a result, trivalent rare earth ions possess very good luminescent characteristics (high colour purity). In particular, luminescence of samarium ions in solids has attracted much attention in recent years to produce reddishorange emitting phosphors for colour display panels [18, 19],